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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Yasuo FUKUDA, et al.

Appln. No.: 09/842,047 ✓

Confirmation No.: 6518

Filed: April 26, 2001

Docket No: Q64291

Allowed: August 2, 2004

Group Art Unit: 3729

Examiner: Thiem D. PHAN

For: METHOD OF FORMING A PROJECTION ELECTRODE

STATEMENT OF SUBSTANCE OF INTERVIEW

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please review and enter the following remarks summarizing the interview conducted on July 23, 2004 between Examiner Thiem Phan and Kevin M. Barner:

REMARKS

An Examiner's Interview Summary Record (PTO-413) was attached with the Notice of Allowability mailed August 2, 2004.

The interview was initiated by the Examiner. Therefore, no further recordation by the Applicant is believed to be required.

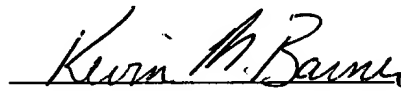
During the interview, Applicants' representative authorized cancellation of the withdrawn claims 1-3 and 8-24 from the application.

It is respectfully submitted that the instant STATEMENT OF SUBSTANCE OF INTERVIEW complies with the requirements of 37 C.F.R. §§1.2 and 1.133 and MPEP §713.04.

STATEMENT OF SUBSTANCE OF INTERVIEW
U.S. Appln. No. 09/842,047

It is believed that no petition or fee is required. However, if the USPTO deems otherwise, Applicant hereby petitions for any extension of time which may be required to maintain the pendency of this case, and any required fee, except for the Issue Fee, for such extension is to be charged to Deposit Account No. 19-4880.

Respectfully submitted,



Kevin M. Barner
Registration No. 46,075

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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: August 31, 2004

Attorney Docket No.: Q64291